

Search Notes

Application/Control No.

10/803,481

Examiner

James D. Stein

Applicant(s)/Patent under
Reexamination

OMORI, OSAMU

Art Unit

2874

SEARCHED

Class	Subclass	Date	Examiner
385	15,33,93,9 4	7/7/2005	JDS

INTERFERENCE SEARCHED

Class	Subclass	Date	Examiner

**SEARCH NOTES
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
See attached EAST search history	7/7/2005	JDS
IEEE and INSPEC: lens, housing, substrate wiring board	7/7/2005	JDS